**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Pan et al.

Serial No.: 09/614,113

Filed: July 12, 2000

For: METHODS OF FORMING A GATE STACK THAT IS VOID OF SILICON CLUSTERS WITHIN A METALLIC SILICIDE FILM THEREOF (AS

AMENDED)

Confirmation No.: 1710

Examiner: D. Deo

Group Art Unit: 1765

Attorney Docket No.: 2269-2915.3US

(96-0149.02/US)

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the Commissioner for Patents (Fax No. 703-308-6916) on the date shown below.

January 9, 2004 Date

Rachael H. Has

PETITION FOR WITHDRAWAL FROM ISSUE TO PERMIT CONSIDERATION OF AN INFORMATION DISCLOSURE STATEMENT UNDER § 1.97 IN A CONTINUING APPLICATION (37 C.F.R. § 1.313(c)(2))

Mail Stop 313(c)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby petition for the withdrawal of this application from issue. The issue fee for this case was paid on October 9, 2003. A copy of the issue fee transmittal is enclosed.

01/13/2004 RKELLEY 00000037 201469 09614113

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130.00 DA 770.00 DA

Serial No.: 09/614,113

The reason for withdrawal of this application from issue is for consideration of an information disclosure statement under 37 C.F.R. § 1.97 in a continuing application. A Request for Continued Examination (RCE) from this application is filed on even date herewith, and a copy of the same is enclosed.

Please charge \$130.00 for the fee associated with this petition to Deposit Account 20-1469, referencing attorney docket no. 2269-2915.3US.

A duplicate of this petition is attached.

Respectfully submitted,

Tawni L. Wilhelm Registration No. 47,456

Attorney for Applicant(s)

TRASKBRITT

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wni I Wilhelm

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Date: January 9, 2004

TLW/ps:rh

Enclosures:

Copy of this Petition

Copy of Part B - Issue Fee Transmittal

Copy of RCE

Document in ProLaw